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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: James M. Holden, William A. McGahan, Richard A. Yarusi, Pablo I. Rovira, and Roger R. Lowe-Webb
Assignee: Nanometrics Incorporated
Title: Apparatus And Method For The Measurement Of Diffracting Structures
Serial No.: 09/670,000 Filing Date: September 25, 2000
Examiner: Unknown Group Art Unit: 2878
Docket No.: M-9455 US

TECHNOLOGY CENTER 2800
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San Jose, California
December 14, 2001

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;

2. a representation that a search has been made; or

3. an admission that the information cited herein is, or is considered to be,

material to patentability as defined in § 1.56(b).

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on December 14, 2001.

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12-14-01
Date of Signature

Respectfully submitted,

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